Electronic Acknowledgement Receipt					
EFS ID:	3543052				
Application Number:	10519475				
International Application Number:					
Confirmation Number:	2692				
Title of Invention:	Plasma processing system and its substrate processing process, plasma enhanced chemical vapor deposition system and its film deposition process				
First Named Inventor/Applicant Name:	Keisuke Kawamura				
Customer Number:	22850				
Filer:	Marvin Jay Spivak/shericka young				
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File Listing:					

File Name

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File Size(Bytes) Multi Pages /Message Digest Part /.zip (if appl.)

1		263788USRCE.pdf	83798	yes	2		
	100		67203cc0e83ae0c723719ff0db7d731b bc341578				
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	Document Description		Start	End			
	Request for Continued Examination (RCE)		1	1			
	Extension of Time		2	2			
Warnings:	•						
Information:							
2	Fee Worksheet (PTO-06)	fee-info.pdf	8397	no	2		
2 Fee Worksneet (F1O-00)	iee-inio.pui	958b31c30f1dde1b24e8d83c3f108731 10e5dfc5	110				
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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.